

Modulation of the second-harmonic generation in MoS₂ by graphene covering*

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Nonlinear optical frequency mixing, which describes new frequencies generation by exciting nonlinear materials with intense light field, has drawn vast interests in the field of photonic devices, material characterization, and optical imaging. Investigating and manipulating the nonlinear optical response of target materials lead us to reveal hidden physics and develop applications in optical devices. Here, we report the realization of facile manipulation of nonlinear optical responses in the example system of MoS₂ monolayer by van der Waals interfacial engineering. We found that, the interfacial engineering of monolayer graphene will weaken the exciton oscillator strength in MoS₂ monolayer and correspondingly suppress the second harmonic generation (SHG) intensity to 30% under band-gap resonance excitation. While with off-resonance excitation, the SHG intensity would enhance up to 130%, which is conjectured to be induced by the interlayer excitation between MoS₂ and graphene. Our investigation provides an effective method for controlling nonlinear optical properties of two-dimensional materials and therefore facilitates their future applications in optoelectronic and photonic devices.

Keywords: two-dimensional materials, second harmonic generation (SHG), graphene, dielectric screening

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1. Introduction

Group VI transition-metal dichalcogenides (TMDs), the representative two-dimensional (2D) materials, have brought us plentiful physics, including strongly bound excitons, valley-selective circular dichroism, 2D topological insulating states, etc.^[1–11] Among these exciting physical properties, efficient nonlinear optical responses, ranging from second harmonic generation (SHG) to high harmonic generation (HHG) have been found in these atomically thin layered materials and attracted tremendous scientific interests.^[12–17] These strong nonlinear optical responses are the fundamental building blocks in the design of advanced optics devices and also bring us unique techniques in material characterization.^[18–21] Manipulation and engineering of the nonlinear properties of 2D materials are of paramount importance for realizing practi-

cal devices. Previously, some methods have been proposed to achieve the modulation of nonlinear optical response in 2D materials, including coupling with waveguides, suffering electron doping or in-plane strain, etc.^[22–30] However, those methods are either complicated in fabrication processes or limited by specific substrates. Therefore, new mechanisms for facile and efficient nonlinear optical response manipulation are still on the way for further exploration.

Van der Waals interfacial engineering is supposed to be an efficient approach to modulate the physical properties of 2D materials. Benefiting from the atomically thin structure, the electron wave functions of 2D materials are distributed at the surface, leading to their sensitive responses to interfacial interaction such as the van der Waals forces.^[31] Recent works have revealed their tunability in electronic, mechanical, optical properties by van der Waals stacking.^[32,33] For examples, flat

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band and superconductivity were observed in bilayer graphene with specific twist angle,^[34] and moiré excitons emerged in TMDs heterostructures.^[35–38] More intriguing phenomenon has also been discovered in twisted bilayer heterojunction, including bandgap opening in graphene with adhering hexagonal boron nitride (h-BN),^[39–41] and strong electron–phonon interaction at TMDs/h-BN interface.^[42] Previously, the SHG from TMDs bilayer/heterostructures has been explored, which can be described by the vector superposition of the SHG electric fields from the individual components.^[43] However, direct modulation of nonlinear optical properties of one layer by another with van der Waals interaction remains largely unexplored.

In this article, we demonstrate that the nonlinear optical responses of 2D materials can be efficiently modulated by exciton oscillator strength under resonant excitation through the modification of the local dielectric environment. Moreover, with restraining the excitons formation by electron doping, this SHG modulation behavior will become faint, exhibiting appealing flexibility in the real device application designing.

2. Methods

Synthesis of MoS₂ MoS₂ monolayer samples were grown on SiO₂ substrate with 300 nm. 10 mg of MoO₃ (99%, Sigma-Aldrich) powder and 2 mg of NaCl (Greagent, 99.95%) were mixed and placed at the center of a tube furnace and 1 g of sulfur (99%, Sigma-Aldrich) powder was placed upstream of a quartz tube. The SiO₂ substrate was placed downstream 8 cm away from the Mo source. The chamber of the furnace was then flushed with argon for an inert atmosphere and subsequently ramped up to the optimized growth temperature (~780 °C) with 100 sccm argon. During growth process, the temperature for sulfur evaporation was ~115 °C. The entire process was carried out under ~150 Pa and the growth duration was set as 10 min. After the growth, the system was naturally cooled to room temperature.

Heterostructure preparation MoS₂ was grown on SiO₂ substrate by chemical vapor deposition method. The graphene monolayer, graphene few-layer, and h-BN were mechanically exfoliated directly on PDMS films. Then, we stamped the PDMS films on the Si/SiO₂ substrate with MoS₂ and slowly released the PDMS. Contacts to the monolayer graphene flake were made using electron-beam evaporation.

PL and Raman measurements All the PL and Raman data were measured by self-built experimental equipment with 532 nm CW solid-state laser. The integral time was set as 5 s for PL measurements and laser power was set as 1 mW. The integral time was 60 s for the Raman measurements under the excitation of 2 mW laser power.

SHG measurements Wavelength-dependent SHG spectra were measured by using Coherent Vira-T oscillator and

optical parametric amplifier (OPA) 9850 laser system (~70 fs, 250 kHz, 1200–1600 nm) excitation. Excitation laser was focused by a Nikon objective (60×, NA = 0.65) and the SHG signal was collected by the same Nikon objective with reflection mode. Through filtering out the excitation laser with a 700 nm short pass filter, SHG signal was recorded by the Princeton SP2500 spectrometer equipped with a nitrogen cooled Si charge coupled devices (CCD). All the experiments were done at room temperature.

3. Results and discussion

In this work, mechanical exfoliated graphene monolayer was transferred onto chemical vapor deposition (CVD) grown MoS₂ monolayer on 300 nm SiO₂/Si substrate via dry transfer method (Fig. 1(b)). The samples were firstly characterized via Raman and photoluminescence (PL) spectra (Fig. S1). In the Raman spectrum of individual MoS₂ and graphene, the standard characteristic peak position and intensity indicate their high quality and monolayer nature. The Raman intensity of MoS₂ is enhanced by ~1.5 times in the heterostructure, indicating a clean and strongly coupled interface.^[44] This interfacial coupling effect can also be observed in the PL spectra, where the PL intensity in MoS₂/graphene heterostructure is quenched to 10% because of electronic coupling and the associated charge/energy transfer process.^[44]

The nonlinear optical response of monolayer MoS₂ was investigated in the atmosphere at room temperature. Under excitation with fundamental frequency ω , the strong second-order susceptibility $\chi^{2\omega}$ of MoS₂ leads to nonlinear polarization $P^{2\omega} = \epsilon_0 \chi^{2\omega} E^\omega E^\omega$ and distinct SHG response. As expected, under femtosecond excitation at 1300 nm, a reflected SHG signal with peak centered at 650 nm was collected (Fig. 1(c)). This frequency harmonic generation phenomenon arises from the up-conversion process which requires instantaneous capture of two near-infrared photons to generate a visible photon. Therefore, the radiated SHG intensity obeys a squared dependence on the fundamental excitation power as shown in Fig. 1(d), where a double-logarithm representation is used for clarity.

Figures 2(a) and 2(b) show the SHG spectra of MoS₂ and MoS₂/graphene heterostructure, where totally different behaviors are exhibited under different wavelength excitation. For 1326 nm excitation, the SHG peak intensity of MoS₂/graphene weakened to 45% compared with that of pristine MoS₂ (Fig. 2(a)). However, the SHG peak intensity enhanced to 130% in the MoS₂/graphene heterostructure with excitation wavelengths of 1420 nm (Fig. 2(b)). As graphene monolayer is inversion symmetric, the second-order optical nonlinearity is electric-dipole forbidden and no SHG signal can be generated. Therefore, the variation of SHG must stem from the modulation of MoS₂ by graphene covering.

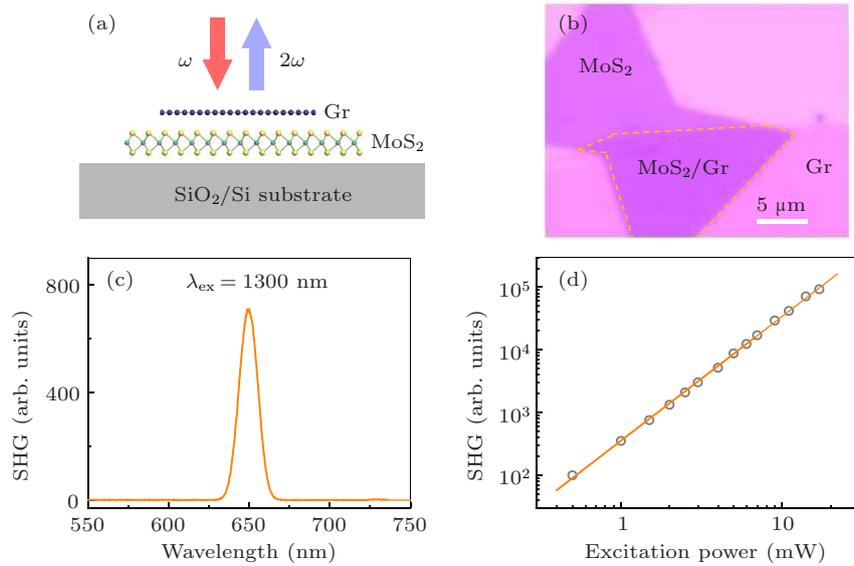


Fig. 1. SHG in MoS₂/graphene heterostructure. (a) Schematic illustration of optical SHG experiments on MoS₂ monolayer and MoS₂/graphene heterostructure. (b) Optical image of MoS₂/graphene. Exfoliated monolayer graphene was transferred on the top of CVD grown monolayer MoS₂ forming MoS₂/graphene heterostructure (in dashed line). Scale bar is 5 μm . (c) Optical SHG spectrum of MoS₂ monolayer under excitation of 1300 nm. (d) The power dependence of SHG peak intensity shows the expected quadratic dependence.

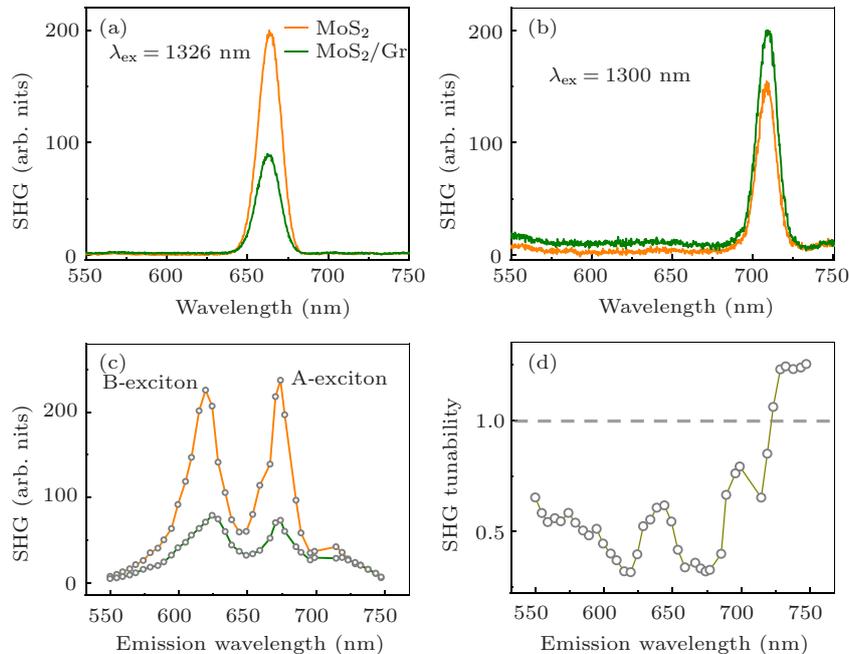


Fig. 2. Wavelength-dependent SHG modulation in MoS₂/graphene heterostructure. (a) Optical SHG spectra of monolayer MoS₂ and MoS₂/graphene heterostructure under excitation of 1326 nm, where the SHG decreased to 45% in the heterostructure. (b) SHG spectra of MoS₂ monolayer and MoS₂/graphene heterostructure under excitation of 1420 nm, where the SHG enhanced up to 130% in the heterostructure. (c) Wavelength-dependent SHG intensity of monolayer MoS₂ and MoS₂/graphene heterostructure. Both curves show peaks around MoS₂ A-exciton and MoS₂ B-exciton. (d) The SHG tunability, which describes the SHG intensity of MoS₂/graphene to that of MoS₂, is plotted. With interfacing graphene, the SHG intensity attenuated to $\sim 30\%$ under resonance excitation, while slightly enhanced under off-resonance excitation.

To further understand this SHG engineering performance, we measured the excitation wavelength dependent SHG spectra of MoS₂/graphene heterostructure and MoS₂ monolayer with tuning excitation wavelengths (Fig. 2(c)). All the two wavelength dependent curves feature two prominent peaks at 675 nm and 620 nm, corresponding to A-exciton and B-exciton of MoS₂, respectively.^[1] Under resonance excitation of exciton states, the SHG intensity is significantly enhanced due to the enhanced light–matter interaction and ex-

citon dipole with strong oscillator strength.^[13] The SHG tunability, which is defined as the ratio of the SHG intensity in MoS₂/graphene to that in pristine MoS₂, is plotted in Fig. 2(d). Wavelength dependent SHG tunability shows that the on-resonance excitation of exciton brings SHG intensity abatement while off-resonance excitation gives SHG intensity enhancement after graphene covering.

This on-resonance SHG weakening can also be gate tunable. Figure 3(a) shows the schematic diagram of our de-

vice, where ion-gel gating was used to controllably tune the chemical potential of the sample. By applying positive gate voltage V_g , the heterostructure will be electron doped, while negative gate voltage means hole doped. As our CVD grown MoS_2 samples are electron doped in nature, the application of a negative gate voltage will bring MoS_2 to charge neutral (Fig. S2). As expected, SHG spectra of both monolayer MoS_2 and $\text{MoS}_2/\text{graphene}$ heterostructure show significant gate tunability under on-resonance excitation of 1340 nm (Fig. S3). Their SHG intensity reaches the maximum at $V_g = -1$ V, and show continuous decrease with voltage increase (Fig. 3(b)). Figure 3(c) shows the gate-dependent SHG tunability of MoS_2 with graphene covering. The SHG tunability is about 43% when V_g is between -2 V and 0 V, where MoS_2 is charge-neutral and A-exciton dominates the optical properties. When V_g goes positive and the formation of charge-neutral exciton is suppressed, on-resonance SHG weakening becomes faint.

We first discuss the on-resonance SHG weakening after covering graphene monolayer. There are mainly three scenarios that could be responsible for this SHG weakening: energy/charge transfer, charge doping, and dielectric screening effect. Though charge/energy transfer process is a common cause for PL quenching, it seems not possible

for nonlinear optical signal decrease observed here. The parametric SHG process, which occurs instantaneously during the excitation pulse (~ 100 fs in our experiments), is ahead the charge/energy transfer process which takes scores of picoseconds after photoexcitation.^[44–46] Meanwhile, the charge/energy transfer process is generally excitation wavelength independent, which happens at both the band edge and deep band in MoS_2 . This is in contrast with the wavelength-dependent SHG modulation we observed. Charge doping can also be excluded from the primary causes, as the SHG intensity of MoS_2 without gating ($V_g = 0$ V) is higher than that of $\text{MoS}_2/\text{graphene}$ at any doping level (Fig. 3(b)).

Dielectric screening effect is believed to be the most reasonable mechanism that responds to the SHG weakening. With graphene covering, the interaction strength between electron and hole in an exciton decreases, resulting in a reduction in spatial overlapping in MoS_2 . As a result, the exciton oscillator strength would be diminished according to the Fermi golden rule (Fig. 4(a)). Since the exciton effects mainly contribute to the SHG response under resonant excitation, the decrease of exciton oscillator strength with graphene covering will surely bring the wavelength-dependent SHG modulation where the SHG weakens under resonance excitation.

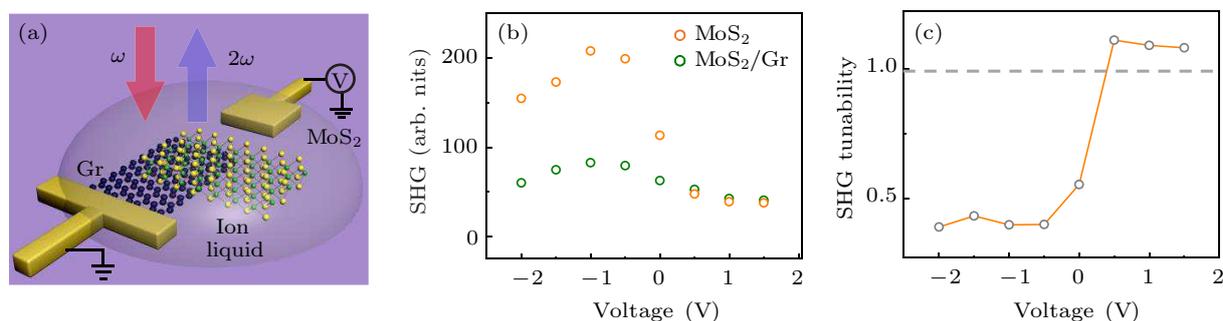


Fig. 3. Gate-dependent SHG in MoS_2 monolayer and $\text{MoS}_2/\text{graphene}$ heterostructure. (a) Schematic of gated $\text{MoS}_2/\text{graphene}$ via ion-gel. (b) Gate voltage dependent SHG in monolayer MoS_2 and $\text{MoS}_2/\text{graphene}$. As our CVD grown MoS_2 is electron doped in nature, the application of negative gate voltage will bring MoS_2 to charge neutral and decline SHG intensity for both MoS_2 monolayer and $\text{MoS}_2/\text{graphene}$ heterostructure. (c) SHG tunability at different gate voltage. At negative gate voltage where MoS_2 is charge-neutral, the SHG tunability can reach 43%. When the gate voltage goes positive and the formation of charge-neutral exciton is suppressed, SHG modulation behavior will become faint. SHG of monolayer MoS_2 is nearly the same as that of heterostructure.

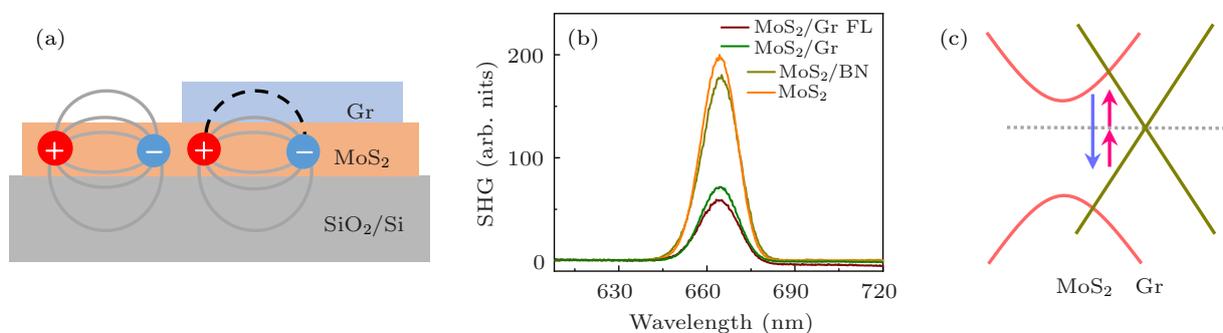


Fig. 4. Mechanisms of SHG modulation in MoS_2 by graphene covering. (a) Schematic illustration of dielectric screening effect in $\text{MoS}_2/\text{graphene}$ heterostructure. With graphene covering, the interaction strength between electron and hole in an exciton decreases, resulting in oscillator strength diminishing. (b) Optical SHG spectra of MoS_2 , MoS_2/BN , $\text{MoS}_2/\text{graphene}$, and MoS_2/Gr few-layer under excitation of 1330 nm. Serving as strong screening dielectric material, graphene declines the SHG intensity of MoS_2 monolayer to 35% at excitation resonance. For MoS_2/Gr few-layer, the SHG further reduces to 30%. While for the covering of insulating h-BN, MoS_2 SHG intensity only decreases to 90%. (c) Schematic of interlayer excitation SHG between MoS_2 and graphene, which may respond for the SHG enhancement under off-resonance excitation.

In the following, we used different dielectric materials to test the screening strength and modulate the SHG intensity. As graphene is semimetal with abundant free carriers and hence provides a strong dielectric screening, the SHG of MoS₂ monolayer weakens to ~35% after adhering monolayer graphene. While for the covering of insulating BN, MoS₂ SHG intensity only decreases to 90% (Fig. 4(b)). Graphene few layers with stronger screening effect bring deeper SHG tunability to ~30%.

Afterwards, we elucidate the mechanism of SHG enhancement with graphene covering under off-resonant excitation. Hot carrier injection and interlayer transition are two main physical processes under near infrared laser excitation, where $2\hbar\omega$ is smaller than the bandgap of MoS₂. Under this condition, MoS₂ is silent with light while graphene can still be excited. The photoexcited hot electrons (rather than holes, because of the band alignment of graphene and MoS₂ shown in Fig. 4(c)) in graphene have chance to overcome the interlayer barrier and inject to MoS₂. While electron doping will decrease the SHG intensity, as we have discussed. Therefore, the hot carrier injection from graphene to MoS₂ cannot be the reason of SHG enhancement we observed. Interlayer excitation between MoS₂ and graphene is conjectured to be the most possible mechanism for the SHG enhancement after graphene covering (Fig. 4(c)). SHG from the heterostructure mainly contains two parts, i.e., one from interaction of virtual states in monolayer MoS₂, and the other from real states transition between the valence band of graphene and conduction band of MoS₂. Under on-resonant excitation, the former one dominates the SHG intensity and the later one can be neglect. As the excitation wavelength increases to off-resonance, the SHG intensity from the former one drops significantly and the later one becomes observable, resulting in the SHG enhancement we detected.

4. Conclusion

In summary, we developed a new method to modulate the SHG of MoS₂ by covering graphene. The SHG intensity of MoS₂/graphene heterostructure was proved to be suppressed at exciton-resonance regime while enhanced away from resonance, correspondingly attributed to the dielectric screening effect and interlayer excitation. Our work has taken a tentative step in dielectric tuning of SHG in 2D materials and promoted deeper understanding in the exciton behaviors. Moreover, our discovery of nonlinear optical response modulation through surrounding dielectric tuning will be very instructive in the design of future nonlinear optoelectrical devices based on 2D materials.

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